

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Akira Izumi

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For: SUBSTRATE PROCESSING METHOD AND SUBSTRATE PROCESSING
APPARATUS

VIA EFS-WEB
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUBMISSION

Sir:

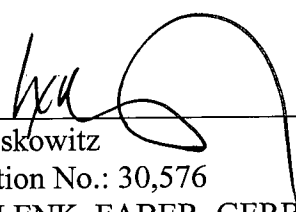
Submitted herewith is a copy of art together with a form listing the same for the convenience of the Examiner.

I certify that each item of information contained in this Submission was cited in a communication from a foreign patent office in a counterpart foreign application and that this communication was not received by any individual designated in 37 C.F.R. 1.56(c) more than 30 days prior to the filing of this Submission. A translation of pertinent parts of the Office Action has been provided in lieu of a Statement of Relevancy of the present invention to the teachings of the cited prior art.

In the event the actual fee is greater than the payment submitted or is inadvertently not enclosed or if any additional fee due during the pendency of this application is not paid, the patent and Trademark Office is authorized to charge the underpayment to Deposit Account No. 15-0700.

Respectfully submitted,

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Enclosures